

In re the Application of: Mamoru NAKASUJI et al.

Group Art Unit: 2881

Serial No.: 09/891,511

Examiner: Jack I. Berman

Filed: June 27, 2001

Confirmation No.: 8779

For: INSPECTION SYSTEM BY CHARGED PARTICLE BEAM AND

METHOD OF MANUFACTURING DEVICES USING THE

**SYSTEM** 

Attorney Docket Number: 010819

Customer Number: 38834

## **PETITION FOR EXTENSION OF TIME**

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

Date: January 31, 2005

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated September 30, 2004 for one (1) month, from December 30, 2004 to January 30, 2005.

Attached please find a check in the amount of \$120.00 to cover the cost of the extension. If any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

02/02/2005 JADDO1

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